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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/805,620
Confirmation No. 3004
Filing Date March 13, 2001
Inventor Craig M. Carpenter
Assignee Micron Technology, Inc.
Group Art Unit 1762
Examiner Kelly M. Stouffer
Attorney's Docket No. MI22-1563
Customer No. 021567
Title: Chemical Vapor Deposition Methods (Amended)

**PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING AND
RESPONSE TO OCTOBER 20, 2006 FINAL OFFICE ACTION**

To: MS RCE
Commissioner for Patents
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AMENDMENTS